

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 277078US0PCT		SERIAL NO. 10/550,534	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Kentarou TAMAKI, et al.			
		FILING DATE		GROUP		September 22, 2005	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
	AO	JP 2000-66051	3/3/2000	Japan (with English Abstract)			X
	AR	JP 2001-83342	3/30/2001	Japan (with English Abstract)			X
	AQ	JP 63-194206	8/11/1988	Japan			X
	AR	JP 61-260208	11/18/1986	Japan			X
	AS	WO 03/010603 A1	2/6/2003	WIPO (with English Abstract)			X
	AT	JP 10-268158	10/9/1998	Japan (with English Abstract)			X
	AU	CN 1285667 A	2/28/2001	China			X
	AV						
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AW	Kentarou TAMAKI, et al. " Photolithographic Properties of Photosensitive Sol-gel Materials and their Application to Optical Waveguides", Journal of Photopolymer Science and Technology Volume 15, Number 1, 2002, Pages 103-108					
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner				Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							